

Docket No.: P-093



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Yoon Kwan LEE

Serial No.: 09/531,759

Confirm. No.: 6134

Filed: March 20, 2000

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: Group Art Unit: 2879
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: Examiner: Michael Henry DAY
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For: BACKPLATE FOR A PLASMA DISPLAY PANEL AND METHOD FOR
FABRICATING THEREOF

REPLY TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents
Washington, D. C. 20231

Sir:

In reply to the Office Action of December 3, 2002 wherein restriction has been required, Applicant hereby elects Group I (claims 1-5), with traverse, for prosecution in the above-identified application.

It is respectfully submitted that the subject matter of each of the designated inventions is sufficiently related that a thorough search for the subject matter of each of the designated inventions would encompass a search for the subject matter of the remaining designated inventions. Thus, it is respectfully submitted that the search and examination of the entire application could be made without serious burden. See MPEP §803 in which it states that "if the search and examination of an entire application can be made without serious burden, the Examiner must examine it on the merits, even though it includes claims to distinct or independent inventions." It is respectfully submitted that this policy should apply in the present

Serial No. 09/531,759

Docket No. P-093

application in order to avoid unnecessary delay and expense to Applicant and duplicative examination by the U.S. Patent and Trademark Office.

If the Examiner believes that any additional changes would place the application in better condition for allowance, the Examiner is invited to contact the undersigned attorney, Daniel Y.J. Kim, at the telephone number listed below.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 16-0607 and please credit any excess fees to such deposit account.

Respectfully submitted,
FLESHNER & KIM, LLP

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Date: December 13, 2002